

The Second Announcement and Call for Papers

The 10th International Conference on Leading Edge Manufacturing in 21st Century (LEM21)

November 14 - 18, 2021

Kitakyushu , Fukuoka, Japan

Venue | Kitakyushu International Conference Center

Sponsored by :

The Japan Society of Mechanical Engineers (JSME)

Organized by :

Manufacturing and Machine Tool Division &

Manufacturing Systems Division



We are pleased to announce that the International Conference on Leading Edge Manufacturing in 21st Century (LEM21) will be held in Kitakyushu, which is "SDGs Future City". For the next generation of humanity in unpredictable societies such as the high frequency of natural disasters and the spread of the Covid-19 virus, researchers and engineers will be able to discuss modern and future topics related to new production technologies and various manufacturing technologies. We offer the opportunity to discuss, exchange, publish and deepen ideas, methods and results.

Organized Sessions:

OS01: Advanced machine tool
OS02: Evaluation of machine tool performance
OS03: Digital manufacturing (CAD,CAM)
OS04: Mechatronics and mechanical elements
OS05: Cutting technology
OS06: Gear manufacturing technology
OS07: Grinding technology
OS08: Finishing technology

OS09: Electro-physical and chemical processes
OS10: Nano/Micro machining and structuring technologies
OS11: Surface and tribology
OS12: Nano/Micro measurement and intelligent instruments
OS13: Additive manufacturing
OS14: Digital manufacturing
OS15: Manufacturing systems, supply chain and scheduling
OS16: Smart Manufacturing (IoT, AI, CPPS)

Conference Style:

LEM21 Kitakyushu is performed in the Hybrid-Flexible (HyFlex) style of virtual conference , in-person conference and on-line conference. However, the participation in a local conference hall will restrict the entrance number for Covid-19 countermeasure.

It will be held by virtual conference from the 2nd day till the 3rd day. The talks by the finalists elected as eminent papers are performed at the international conference hall (or on-line) on the 4th day of the conference. It is encouraged that finalists participate in the conference at the local conference hall.

Other participants are restricted to participation on line. Only those who are permitted will participate in the international conference hall.

The talks will become available at any time during the conference as on-demand videos.

About Conference Awards:

Several awards are granted to eminent papers.

CONFERENCE BEST PAPER AWARDS: Awarded for outstanding papers of 4 pages or more contributed to LEM21.

YOUNG RESEARCHER AWARD: The first author of a prominent paper, awarded to young presenters up to the age of 26 as of April 2022.



YOUNG FELLOW AWARD: Among the candidate papers for the Young Researcher Award, the most prominent papers with 4 pages or more will be awarded.

These awards will be commended in the award ceremony of the 4th day of the Conference.

Special Issue to International Journals:

As for the eminent paper in all the presented papers, contributing recommendation is performed to the special issue of JAMDSM. (Journal of Advanced Mechanical Design, Systems, published by JSME).

We also recommend contributions to the IJAT special issue. (International Journal of Automation Technology, published by Fuji Technology Press).

Important dates:

Deadline of paper application with abstract:	March 31, 2021
Notification of tentative acceptance based on abstract:	April 20, 2021
Deadline of camera - ready manuscript submission:	May 31, 2021
Notification of paper acceptance:	June 30, 2021
Deadline of final camera - ready manuscript:	July 31, 2021

Abstract submission:

An abstract of about 400 words in English in one page of A4 size is required for every paper. Please download the abstract submission form (in Microsoft Excel format) from the conference website. Fill it out and submit it by e - mail to:

lem21_rmmt@jsme.or.jp (LEM21 Program Committee)

The submission deadline is: **March 31, 2021**.

Conference registration fee:

Regular:

Early registration (before Sept. 20)

JSME member:	50,000 JPY
non-member:	60,000 JPY

Late registration

JSME member:	60,000 JPY
non-member:	65,000 JPY

Student:

JSME student member:	25,000 JPY
non-member:	35,000 JPY

Banquet:

All participants:	10,000 JPY
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The registration fee includes one copy of the conference proceedings. For multiple presentation by the same participant, 10,000 JPY is charged per one additional presentation. Additional copy of the conference proceedings is 10,000 JPY for JSME members (15,000 JPY for non-members).

Venue:

Kitakyushu Convention Center

Located 2-minute walk from JR Kokura station. <https://convention-a.jp/kokusai-kaigi/>

General contact:

Email: lem21_rmmt@jsme.or.jp

Conference webpage:

<http://www.jsme.or.jp/mmt/lem21Kitakyushu/>



Conference Committee:

- General Chair: Hiroyuki Narahara, Professor, Kyushu Institute of Technology
Conference Co - chairs: Atsushi Matsubara, Professor, Kyoto University
Yasushi Umeda, The University of Tokyo
Makoto Fujishima, DMG Mori Co., Ltd.
Keisuke Suzuki, Professor, Kyushu Institute of Technology
- Program Chairs: Gao Feng, Professor, Nishinippon Institute of Technology
Terutake Hayashi, Assoc. Prof., Kyushu University
Hiroshi Koresawa, Assoc. Prof., Kyushu Institute of Technology
- Secretariats: Naoki Mori, Professor, Kyushu Institute of Technology
Koichi Kikkawa, Assoc. Prof., Kyushu Institute of Technology
- Executing Committee: Teruyuki ASAO, Professor, National Institute of Technology, Kitakyushu College
Yoshifumi AMAMOTO, Assoc. Prof., Fukuoka Institute of Technology
Akihisa KUBOTA, Assoc. Prof., Kumamoto University
Hiroshi MURAKAMI, Assoc. Prof., The University of Kitakyushu
Sunao MURAKAMI, Assoc. Prof., Kyushu Institute of Technology
Khajorurungruang PANART, Assoc. Prof., Kyushu Institute of Technology
Hiroki SHIMIZU, Assoc. Prof., Kyushu Institute of Technology

OS and Organizers:

- OS01: Advanced machine tool
*Yoshitaka MORIMOTO, *Hayato YOSHIOKA
Yohichi NAKAO, Keiichi SHIRASE
- OS02: Evaluation of machine tool performance
*Yukitoshi IHARA, Soichi IBARAKI
Akinori SAITO
- OS03: Digital manufacturing (CAD, CAM)
* Koichi MORISHIGE, Jun'ichi KANEKO
Hideki AOYAMA, Fumiki TANAKA
Koji TERAMOTO, Keiichi NAKAMOTO
- OS04: Mechatronics and mechanical elements
*Yasuhiro KAKINUMA, Atsushi MATSUBARA
Tadahiko SHINSHI, Ryuta SATO
Toshiki HIROGAKI, Alan HASE
- OS05: Cutting technology
*Takashi MATSUMURA, Hideharu KATO
Ryutaro TANAKA, Hirohisa NARITA
Norikazu SUZUKI, Jun'ichi KANEKO
Katsuhiko SAKAI, Masahiko JIN
Hiromi ISOBE, Masato OKADA
Yoshio MIZUGAKI, Shigehiko SAKAMOTO
- OS06: Gear manufacturing technology
*Naohiko SUGITA, Jiwang YAN
Shuheji KUROKAWA, Yukihisa NISHIMURA
- OS07: Grinding technology
*Kazuhiro OHASHI, Libo ZHOU
Takazo YAMADA, Takayuki KITAJIMA
Masakazu Fujimoto, Akinori YUI
Nobuhito YOSHIHARA, Weimin LIN
- OS08: Finishing technology
*Toshiyuki ENOMOTO, Hitomi YAMAGUCHI
Yanhua ZOU, Kenichiro YOSHITOMI
Osamu ONISHI, Keisuke SUZUKI
Akihisa KUBOTA, Hideo TAKINO
- OS09: Electro-physical and chemical processes
*Akira OKADA, *Hirofumi HIDAI
Shinya HAYAKAWA, Tohru ISHIDA
Keiji YAMADA, Yasuhiro OKAMOTO
Keiji OGAWA, Akiteru HAYASHI
- OS10: Nano/Micro machining and structuring technologies
*Masayoshi MIZUTANI, *Hirofumi SUZUKI
Mitsuyoshi NOMURA, Noboru TAKANO
Jiwang YAN
- OS11: Surface and tribology
*Masahiko YOSHINO, Noritsugu UMEHARA
Jun TANIGUCHI, Arata KANEKO
Fumihiro ITOIGAWA, Takanori YAZAWA
Sunao MURAKAMI, Motoki TERANO
- OS12: Nano/Micro measurement and intelligent instruments
*Yasuhiro TAKAYA, Satoru TAKAHASHI
Wei GAO, Kazuhide KAMIYA
Terutake HAYASHI, Shinya MORITA
Yasuhiro MIZUTANI, Hiroki SHIMIZU
Hiroshi MURAKAMI, So Ito
- OS13: Additive manufacturing
*Hiroyuki NARAHARA, *Hiroyuki SASAHARA
Tatsuaki FURUMOTO, Takeyuki ABE
Ryo KOIKE, *Toshitake TATENO
Tomohisa TANAKA, Hirohisa NARITA
- OS14: Digital manufacturing
*Hironori HIBINO, Hajime MIZUYAMA
Taiki OGATA
- OS15: Manufacturing systems, supply chain and scheduling
*Rei HINO, Yoo JAEKYU
Keisuke MURAKAMI, Eiji MORINAGA
- OS16: Smart Manufacturing (IoT, AI, CPPS)
*Sharif ULLAH, Hiroyuki SAWADA
Koji IWAMURA, Nobutada FUJII
Kazunori MARUYAMA, Yasushi UMEDA